

Special Issue

Smart Sensors 2020

Message from the Guest Editors

The 2020 International Conference on Smart Sensors (ICSS) will be held on 22–23 June 2020 at National Sun Yat-sen University, Kaohsiung, Taiwan. As with last year, the conference is a joint event of the 25th Symposium of Association for Chemical Sensors in Taiwan and the 23rd Nano Engineering and Microsystem Technology Conference. This Special Issue will publish both selected papers from ICSS 2020 and external papers. The topics to be covered include but are not limited to:

- Chemical Sensors
- Biosensors
- Microfluidics for Medical Applications
- MEMS and NEMS Fabrication
- Microfluidics
- Applied MEMS and Applied Microfluidics

We encourage both original research papers and comprehensive review articles to be submitted to this Special Issue.

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Deadline for manuscript submissions

closed (30 April 2021)



Micromachines

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Message from the Editor-in-Chief

You are invited to contribute research articles or comprehensive reviews for consideration and publication in *Micromachines* (ISSN 2072-666X). *Micromachines* is published in the open access format. Research articles, reviews and other contents are released on the internet immediately after acceptance. The scientific community and the general public have unlimited free access to the content as soon as it is published. As an open access journal, *Micromachines* is supported by the authors or their institutes by payment of article processing charges (APC) for accepted papers. We are pleased to welcome you as our authors.

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